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By: Wm. Sun

Date: August 10, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/904,360 Conf. No.: 1413  
Applicant : Giuseppe Curello et al.  
Filed : July 12, 2001  
Title : Process for Producing a Doped  
Semiconductor Substrate  
TC/A.U. : 2825  
Examiner : Igwe U. Anya  
Customer No. : 24131

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S U P P L E M E N T A L R E S P O N S E

S i r :

Supplemental to the amendment filed on June 29, 2004 and responsive to the Office action dated March 29, 2004, kindly enter the Declaration under 37 C.F.R. 1.131, submitted herewith.

Remarks/Arguments begin on page 2 of this paper.